

EAST Search History

Ref #	Hits	Search Query	DBS	Default Operator	Plurals	Time Stamp
S1	0	(Polishing adj pad with (polyurethane polyolefin polyvinylalcohol polyvinylacetate polycarbonate (polyacrylic adj acid) polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyamide polyimide polytetrafluoroethylene polyetheretherketone)) and ("poisson's" adj ratio)	US-PPGPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/24 15:08
S2	0	(Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes polyesters polyamides polyimides polytetrafluoroethylenes polyetheretherketone)) and ("poisson's" adj ratio)	US-PPGPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/09/24 09:24
S3	6	("poisson's" adj ratio) with negative	US-PPGPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/09/24 09:25
S4	19	(US-6517417-\$ or US-6648733-\$ or US-6641471-\$ or US-6705934-\$ or US-6095902-\$ or US-6171181-\$ or US-6099954-\$ or US-6077785-\$ or US-6387312-\$ or US-6206759-\$ or US-6325703-\$ or US-6045716-\$). did or (US-20030220061-\$ or US-20030003857-\$ or US-20020197935-\$ or US-20020077036-\$ or US-20030216111-\$ or US-20010024940-\$ or US-20010031610-\$).did.) and	US-PPGPUB; USPAT	OR	OFF	2004/09/24 10:04

EAST Search History

S5	13	(US-6517417-\$ or US-6648733-\$ or US-6641471-\$ or US-6705934-\$ or US-6095902-\$ or US-6171181-\$ or US-6099954-\$ or US-6077785-\$ or US-6387312-\$ or US-6206759-\$ or US-6325703-\$ or US-6045716-\$). did or (US-20030220061-\$ or US-20020197935-\$ or US-20020077036-\$ or US-20030216111-\$ or US-20010024940-\$ or US-20010031610-\$).did.) and	US-PPGPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/10/05 14:41
S6	31	(Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones) and density	US-PPGPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/09/24 10:05
S7	31	Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones) and density	US-PPGPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/09/24 10:08
S8	142	"poison's" adj ratio	US-PPGPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/09/24 11:48
S9	2	((4,668,557" or "4,688,557" or "5,195,353" or "5,284,435" or "5,512" or "5,391,516" or "5,433,651" or "5,489,233" or "5,609,511" or "5,643,046" or "5,653,183" or "5,739,642" or "5,838,447" or "5,872,633" or "5,893,796" or "5,949,927" or "5,964,643" or "6,062,968" or "6,126,532" or "6,203,407" or "6,454,634").pn.) and ("poison's" adj ratio)	US-PPGPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/09/24 11:48

EAST Search History

S10	40	US-PGPUB; USPAT; EPO; JPO; DERVENT	OFF	2004/09/24 11:51
		("4,668,557" or "4,688,557" or "5,131,414" or "5,284,435" or "5,314,512" or "5,433,651" or "5,391,516" or "5,489,233" or "5,609,511" or "5,633,046" or "5,658,183" or "5,73,962" or "5,838,447" or "5,872,633" or "5,893,796" or "5,949,927" or "5,964,643" or "6,062,968" or "6,126,532" or "6,203,407" or "6,454,634"), pn), not a Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polycrylic adj acids) polyacrylamides polyethylenes polypropylenes mylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones))	OFF	2004/09/24 11:52
S11	20	US-PGPUB; USPAT; EPO; JPO; DERVENT	OFF	2004/09/24 11:52
		(Polishing adj pad) and ((("4,668,557" or "4,688,557" or "5,196,353" or "5,284,435" or "5,314,512" or "5,391,516" or "5,433,651" or "5,489,233" or "5,609,511" or "5,643,046" or "5,658,183" or "5,739,642" or "5,838,447" or "5,872,633" or "5,893,796" or "5,949,927" or "5,964,643" or "6,062,968" or "6,126,532" or "6,203,407" or "6,454,634"),pn))	OFF	2004/09/24 11:52
S13	46	US-PGPUB; USPAT; EPO; JPO; DERVENT	OFF	2004/09/24 15:55
		Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polycrylic adj acids) polyacrylamides polyethylenes polypropylenes mylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones))	OFF	2004/09/24 15:55

EAST Search History

514	1	((Polishing adj pad with (polyurethane polyolefin polyvinylalcohol polyvinylacetate polycarbonate (polyacrylic adj acid) polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyamide polyimide polytetrafluoroethylene polyetheretherketone)) or (Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes mylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones)) and (strain and ((bulk or ("Young's") or shear) adj modulus)))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OFF	2004/09/24 16:17
	8	((Polishing adj pad with (polyurethane polyolefin polyvinylalcohol polyvinylacetate polycarbonate (polyacrylic adj acid) polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyamide polyimide polytetrafluoroethylene polyetheretherketone)) or (Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes mylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones)) and (strain and ((bulk or ("Young's") or shear) adj modulus)))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OFF	2004/09/24 16:17
515					

EAST Search History

S16	250	((Polishing adj pad with (polyurethane polyolefin polyvinylalcohol polyvinylacetate polycarbonate (polyacrylic adj acid) polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyamide polyimide polytetrafluoroethylene polyetheretherketone)) or (Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones)) and (strain or modulus))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 10:03
S17	115	((Polishing adj pad with (polyurethane polyolefin polyvinylalcohol polyvinylacetate polycarbonate (polyacrylic adj acid) polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyamide polyimide polytetrafluoroethylene polyetheretherketone)) or (Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones)) and (strain or ("bulk" or ("young's") or shear adj modulus))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 10:06

EAST Search History

S18	168	((Polishing adj pad with (polyurethane polyolefin polyvinylalcohol polyvinylacetate polycarbonate (polyacrylic adj acid) polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyamide polyimide polytetrafluoroethylene polyetheretherketone)) or (Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones)) and (modulus))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 10:06
S19	40	((4,668,557" or "4,688,557" or "5,196,353" or "5,284,435" or "5,314,512" or "5,391,516" or "5,433,651" or "5,489,233" or "5,609,511" or "5,643,046" or "5,658,183" or "5,739,642" or "5,838,447" or "5,872,633" or "5,893,795" or "5,949,927" or "5,964,643" or "6,062,968" or "6,126,532" or "6,203,407" or "6,454,634") ,pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 14:28
S20	655	(Polishing adj pad with ((void adj volume) or (pore adj (density or diameter)) or grooves))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 15:05
S21	0	(Polishing adj pad with (void adj volume))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 15:50
S22	912	(Polishing adj pad with groove\$)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 15:06
S23	13	(Polishing adj pad with (pore adj (density or diameter)))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 15:06
S24	9	(Polishing adj pad with (linear adj groove\$))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2004/10/04 15:13

EAST Search History

S25	13	(Polishing adj pad with (void adj volume))	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/10/05 13:53	
S26	5	5 (((Polishing adj pad with (pore adj (density or diameter))) and ((Polishing adj pad with (void adj volume)))	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/10/04 15:52	
S27	135	((Polishing adj pad with (polyurethane polyol) poly(vinylacetate polycarbonate (polycrylic adj acid) polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyamide polyimide polytetrafluoroethylene polyetheretherketone) or (Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones) and (modulus)) not (((Polishing adj pad with (polyurethane polyol) polyol) polyvinylalcohol polyvinylacetate polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyamide polyimide polytetrafluoroethylene polyetheretherketone) or (Polishing adj pad with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polyethers polyamides polytetrafluoroethylenes polyetheretherketones) and (strain or ((bulk or ("Young's") or shear adj modulus)))	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/10/05 08:51	
S28	319	Elastollan C-64D	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/10/05 08:52	

EAST Search History

S29	0	"Elastollan C-64D"	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/10/05 08:51	
S30	0	Elastollan and "C-64D"	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/10/05 08:52	
S31	319	Elastollan	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/10/05 08:54	
S32	1	Elastollan and (polishing adj pad)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/10/05 08:55	
S33	26	(Polishing adj pad with (in situ))	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/10/05 13:53	
S34	14	(Polishing adj pad with (in situ) and (transparent lens transmissive optics plug))	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/10/05 13:55	
S35	0	"20020182856".URPN.	USPAT	OR	OFF	2004/10/05 14:23	
S36	0	"20020182856".URPN.	USPAT	OR	OFF	2004/10/05 14:24	
S37	0	"20020182856".URPN.	USPAT	OR	OFF	2004/10/05 14:24	
S38	2	"60955902".pn.	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/10/06 09:42	
S39	2	"6126532".pn.	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/10/06 09:38	
S40	1	"5893795".pn. and wavelength	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/10/06 09:39	
S41	2	"6120353".pn.	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/10/06 10:15	
S42	1	"5949927".pn. and pad	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2004/10/06 10:15	

EAST Search History

S44	25	("45" clas.) and ("re-entrant" or auxetic)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2005/11/29 13:52	
S45	4	("polishing adj pad) and ("re-entrant" or auxetic)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2005/11/29 13:56	
S46	40	auxetic	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2005/11/29 13:56	
S47	2034	Polishing adj pad with (polurethane polyolefin polyvinylalcohol polyvinylacetate polycarbonate (polycrylic adj acid) polyacrylamide polyethylene polypropylene nylon fluorocarbon polyester polyether polyetherketone) 10/754390.app.	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2005/11/29 15:07	
S48			US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/23 15:13	
S49	627	(polishing adj pad) and ((expand\$4 near20 expand\$4) or (contract\$4 near20 contract\$4) or (compress\$6 near20 compress\$6)) (polishing adj pad) same ((expand\$4 near20 expand\$4) or (contract\$4 near20 contract\$4) or (compress\$6 near20 compress\$6)) (polishing adj pad) and Poisson\$4	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/24 15:09	
S50	210		US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/24 15:17	
S51	11		US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/24 15:37	
S52	9	(polishing adj pad) and (("anti-rubber" or ("anti near rubber)) or dilation\$6 or auxetic\$6)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/24 15:46	
S53	57	(CMP "chemical mechanical polishing" "chemical mechanical planarizing") and ((("anti-rubber" or ("anti near rubber)) or dilation\$6 or auxetic\$6) (CMP "chemical mechanical polishing" "chemical mechanical planarizing") and (auxetic\$6))	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/24 15:44	
S54	0	(CMP "chemical mechanical planarizing") and (auxetic\$6)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/24 15:43	

EAST Search History

S55	57	(CMP "chemical mechanical polishing" "chemical mechanical planarizing") and (dilation\$6)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/24 15:44	
S56	0	(CMP "chemical mechanical polishing" "chemical mechanical planarizing") and ("anti-rubber" or (anti near rubber))	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/24 15:44	
S57	0	(CMP "chemical mechanical polishing" "chemical mechanical planarizing") and (dilation\$6)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/24 15:44	
S58	417	hysteresis and Poisson\$5	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/24 15:46	
S59	207	hysteresis and Poisson\$5 and negative	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/24 15:48	
S60	124	S59 and ((polishing adj pad) CMP "Chemical mechanical polishing" "Chemical mechanical" wafer substrate semiconductor\$4)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 11:04	
S61	0	S59 and (polishing adj pad)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 11:04	
S62	22	hysteresis and (Poisson\$5 with negative)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/24 15:48	
S63	227	(Poisson\$5 with negative)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/24 15:48	
S64	114	(Poisson\$5 near2 negative)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/24 16:26	
S65	36	S64 and ((polishing adj pad) CMP "Chemical mechanical polishing" "Chemical mechanical" wafer substrate semiconductor\$4)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 09:10	
S66	8	("re-entrant" or reentrant or auxetic) and (polishing adj pad)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 09:16	

EAST Search History

S67	409	("re-entrant" or reentrant or auxetic) and (CMP "chemical mechanical planarizing")	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 09:17	
S68	326	("re-entrant" or auxetic) and (CMP "chemical mechanical polishing" "chemical mechanical planarizing")	US-PCPUB; OR USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 09:18	
S69	0	(auxetic) and (CMP "chemical mechanical polishing" "chemical mechanical planarizing")	US-PCPUB; OR USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 09:17	
S70	95	((("re-entrant" or auxetic) and (CMP "chemical mechanical polishing" "chemical mechanical planarizing")) not ("re-entrant" near6 (bend angle angles trenches)))	US-PCPUB; OR USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 09:24	
S71	32	((negative near2 Poisson\$4) or auxetic or auxetics\$4 or dilational or (anti adj rubber) or "anti-rubber") with (properties property)	US-PCPUB; OR USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 09:25	
S72	46	((negative near2 Poisson\$4) or auxetic or auxetics\$4 or dilational or (anti adj rubber) or "anti-rubber") with (properties property advantage\$4)	US-PCPUB; OR USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 09:26	
S73	0	((negative near2 Poisson\$4) or auxetic or auxetics\$4 or dilational or (anti adj rubber) or "anti-rubber") with (polyurethanes polyolefins polyvinylalcohols polyvinylacetates polycarbonates (polyacrylic acid) polyacrylamides polyethylene polypropylenes nylons fluorocarbons polyesters polyethers polyamides polyimides polytetrafluoroethylenes polyetheretherketones)	US-PCPUB; OR USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 09:39	
S74	30	((negative near2 Poisson\$4) or auxetic or auxetics\$4 or dilational or (anti adj rubber) or "anti-rubber") with (polymer)	US-PCPUB; OR USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 09:40	
S75	33	((negative near2 Poisson\$4) or auxetic or auxetics\$4 or dilational or (anti adj rubber) or "anti-rubber") with (polymer polymers polymeric) S75 and S77	US-PCPUB; OR USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 10:12	
S76	16		US-PCPUB; OR USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 10:12	

EAST Search History

S77	0	(polishing adj pad) same (polymeric adj foam) and strength and (abrasion adj resist\$4) and (tear adj resist\$4)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 11:05	
S78	0	((polishing adj pad) same (polymeric adj foam) and strength and (abrasion adj resist\$4))	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 11:06	
S79	5	((polishing adj pad) same polymer same foam) and strength and (abrasion adj resist\$4)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 11:12	
S80	5	((polishing adj pad) same polymer2 same foam) and (polymer\$2 same foam) and strength and (abrasion adj resist\$4)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 11:12	
S81	20	((polishing adj pad) and (polymer\$2 same foam) and strength and (abrasion adj resist\$4))	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/11/14 11:13	
S82	0	("volumetric compression ratio") and (polishing adj pad)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 11:28	
S83	0	(volume\$6 near3 compression near3 ratio) and (polishing adj pad)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 11:29	
S84	23	((polishing adj pad) and (\$polyester\$4 same foam) and strength and (abrasion adj resist\$4))	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/05/25 13:08	
S85	2	"4668557".pn.	US-PCPUB; USPAT; USOCR; EPO; JPO; DERVENT	OR	OFF	2006/05/26 11:06	
S86	1	10/457316.app.	US-PCPUB; USPAT; USOCR; EPO; JPO; DERVENT	OR	OFF	2006/05/26 11:07	
S87	9	(polyester adj foam) and ((polishing planarizing) adj pad\$1)	US-PCPUB; USPAT; USOCR; EPO; JPO; DERVENT	OR	OFF	2006/05/26 12:13	

EAST Search History

S88	75	((polishing planarizing) adj pad\$1) and ((polyester and (polyurethane\$4 polyolefin\$4)) with foam) and abrasive	US-PCPUB; USPAT; USOCR; EPO; JPO; DERVENT	OR	OFF	2006/05/26 11:16		
S89	45	((polishing planarizing) adj pad\$1) and ((polyester and (polyurethane\$4 polyolefin\$4)) with foam) and abrasive and (CMP "chemical mechanical polishing" "chemical mechanical planarizing")	US-PCPUB; USPAT; USOCR; EPO; JPO; DERVENT	OR	OFF	2006/05/26 11:18		
S90	45	((polishing planarizing) adj pad\$1) and ((polyester with foam) and (polyurethane\$4 polyolefin\$4)) with foam) and abrasive and (CMP "chemical mechanical polishing" "chemical mechanical planarizing")	US-PCPUB; USPAT; USOCR; EPO; JPO; DERVENT	OR	OFF	2006/05/26 11:18		
S91	2	"6556018".pn.	US-PCPUB; USPAT; USOCR; EPO; JPO; DERVENT	OR	OFF	2006/05/26 12:02		
S92	308	(polyester adj foam) with polyurethane	US-PCPUB; USPAT; USOCR; EPO; JPO; DERVENT	OR	OFF	2006/05/26 12:02		
S93	6	(polyester adj foam) with polyurethane with based	US-PCPUB; USPAT; USOCR; EPO; JPO; DERVENT	OR	OFF	2006/05/26 12:02		
S94	52	(polyester near\$4 foam) and ((polishing planarizing) adj pad\$1)	US-PCPUB; USPAT; USOCR; EPO; JPO; DERVENT	OR	OFF	2006/05/26 12:13		
S95	17	(polyester near\$4 foam) and ((polishing planarizing) adj pad\$1) and (CMP "chemical mechanical polishing" "chemical mechanical planarizing")	US-PCPUB; USPAT; USOCR; EPO; JPO; DERVENT	OR	OFF	2006/05/26 12:13		
S96	27	(polishing adj pad) and (polymer\$2 same foam) and (abrasion adj resist\$4)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2006/11/14 11:14		
S97	27	(polishing adj pad) and (polymer\$2 same foam) and (abrasion near resist\$4)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2007/06/29 09:18		

EAST Search History

S98	2	"4668557".pn.	US-PCPUB; USPAT; USOCR; EPO; JPO; DERVENT	OR	OFF	2007/04/23 15:02		
S99	38	(polishing adj pad) and ((polyester\$4 polyether\$4) same foam) and (abrasion near resist\$4)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2007/06/29 10:53		
S100	35	(polishing adj pad) and (polymer\$2 same foam) and (abrasion near resist\$4)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2007/06/29 09:18		
S101	8	\$99 not \$100	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2007/06/29 09:25		
S102	0	E002/46283	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2007/06/29 09:26		
S103	1	W002/46283	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2007/06/29 09:26		
S104	68	(polishing adj pad) same (abrasion near resist\$4)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2007/06/29 10:54		
S105	36	(polishing adj pad) with (abrasion near resist\$4)	US-PCPUB; USPAT; EPO; JPO; DERVENT	OR	OFF	2007/06/29 10:54		